

2223

DOCKET: CU-2636

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Sang Ick LEE et al.]
Serial No.: 09/994,284]
Filed: 26 November 2001]
For: METHOD OF FORMING METAL]
GATE IN SEMICONDUCTOR]
DEVICE]

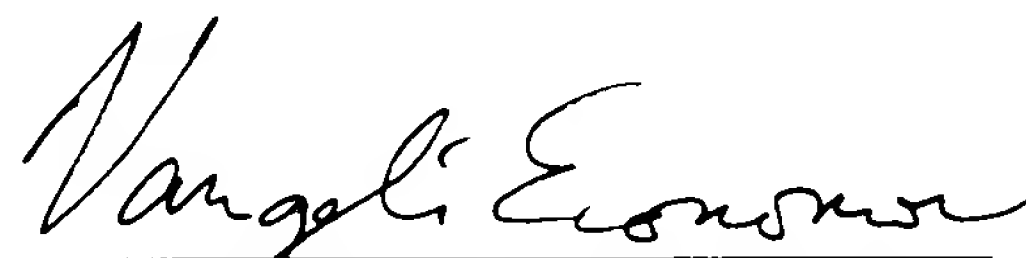
Group Art Unit: 2823

Examiner: Pham, Thanh V.

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Certification under 37 C.F.R. §1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, on July 17, 2003.


Vangelis Economou - Reg. No. 32,341

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Official Action dated March 25, 2003, Applicants submit contemporaneously herewith a Request for Extension of Time, extending the period of response for one month from June 25, 2003 to July 25, 2003. In response to the substance of the Action, please consider the following remarks in the above-identified application.

IN THE CLAIMS:

Please substitute the following amended Claim 1 for pending Claim 1.